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EXAMINER

LEWIS, MONICA

ART UNIT PAPER NUMBER

2822

DATE MAILED: 07/30/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

09/939,417

Applicant(s)

FORBES, LEONARD

Examiner

Monica Lewis

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-- **Th MAILING DATE of this communication appears on th cover sh et with the correspondence address --**
Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 12 May 2003.
- 2a) ☒ This action is **FINAL**. 2b) ☐ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-22 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1-22 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☒ The drawing(s) filed on 24 August 2001 is/are: a) ☒ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- 11) ☐ The proposed drawing correction filed on _____ is: a) ☐ approved b) ☐ disapproved by the Examiner.
If approved, corrected drawings are required in reply to this Office action.
- 12) ☐ The oath or declaration is objected to by the Examiner.

Priority under 35 U.S.C. §§ 119 and 120

- 13) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
2. ☐ Certified copies of the priority documents have been received in Application No. _____.
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).
* See the attached detailed Office action for a list of the certified copies not received.
- 14) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).
a) ☐ The translation of the foreign language provisional application has been received.
- 15) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.

Attachment(s)

- 1) ☒ Notice of References Cited (PTO-892) 4) ☐ Interview Summary (PTO-413) Paper No(s). _____
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948) 5) ☐ Notice of Informal Patent Application (PTO-152)
- 3) ☐ Information Disclosure Statement(s) (PTO-1449) Paper No(s) _____ 6) ☐ Other: _____

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DETAILED ACTION

1. This office action is in response to the amendment filed May 12, 2003.

Claim Rejections - 35 USC § 103

2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

3. Claims 1-15 and 18-22 are rejected under 35 U.S.C. 103(a) as obvious over Forbes et al. (U.S. Patent No. 5,936,274) in view of Kouznetsov et al. (U.S. Publication No. 2002/0142546) and Cleeves et al. (U.S. Patent No. 6,580,124).

In regards to claim 1, Forbes et al. ("Forbes") discloses the following:

- a) a pillar (300) of semiconductor material that extends outwardly from a working surface of a substrate (305) to form a source region (310), a body region (320) and a drain region (315) of a floating gate transistor (For Example: See Figure 3A); and
- b) a floating gate (325) along one side of the pillar (For Example: See Figure 3A).

In regards to claim 1, Forbes fails to disclose the following:

- a) a control gate overlaying the floating gate.

However, Kouznetsov et al. ("Kouznetsov") discloses a semiconductor device that has a control gate overlaying a floating gate (See Figure 7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a control gate overlaying a floating gate as disclosed in Kouznetsov because it aids in increasing memory density (For Example: See Paragraph 24).

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Additionally, since Forbes and Kouznetsov are both from the same field of endeavor, the purpose disclosed by Kouznetsov would have been recognized in the pertinent art of Forbes.

b) floating gate overlaps the body region in a horizontal direction.

However, Cleeves et al. ("Cleeves") discloses a semiconductor device that has a floating gate that overlaps the body region in a horizontal direction (For Example: See Figure 2p). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a control gate overlaying a floating gate as disclosed in Kouznetsov because it aids in storing data in a nonvolatile manner (For Example: See Column 1 Lines 5-49).

Additionally, since Forbes and Cleeves are both from the same field of endeavor, the purpose disclosed by Cleeves would have been recognized in the pertinent art of Forbes.

In regards to claim 2, Forbes discloses the following:

a) charges are selectively stored in the floating gate in programming the floating gate transistor (For Example: See Column 7 Lines 8-28).

In regards to claim 3, Forbes discloses the following:

a) the pillar is formed by etching (For Example: See Figure 7).

Additionally, the limitation of "pillar is formed by etching" makes it a product by process claim. The MPEP § 2113, states, "Even though product -by[-] process claims are limited by and defined by the process, determination of patentability is based upon the product itself. The patentability of a product does not depend on its method of production. If the product in product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product is made by a different process." *In re Thorpe*, 227 USPQ 964, 966 (Fed. Cir. 1985)(citations omitted).

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A "*product by process*" claim is directed to the product per se, no matter how actually made, *In re Hirao and Sato et al.*, 190 USPQ 15 at 17 (CCPA 1976) (footnote 3). See also *In re Brown and Saffer*, 173 USPQ 685 (CCPA 1972); *In re Luck and Gainer*, 177 USPQ 523 (CCPA 1973); *In re Fessmann*, 180 USPQ 324 (CCPA 1974); and *In re Marosi et al.*, 218 USPQ 289 (CAFC 1983) final product per se which must be determined in a "*product by, all of*" claim, and not the patentability of the process, and that an old or obvious product, whether claimed in "*product by process*" claims or not. Note that Applicant has the burden of proof in such cases, as the above caselaw makes clear.

In regards to claim 4, Forbes discloses the following:

a) an absence or a presence of stored charges on the floating gate determines a conductivity state of the transistor between the source region and the drain region (For Example: See Column 8 Lines 8-27).

In regards to claim 5, Forbes discloses the following:

a) the substrate is a bulk semiconductor substrate (For Example: See Column 1 Lines 47-49).

In regards to claim 6, Forbes discloses the following:

a) the substrate is a silicon on-insulator substrate (For Example: See Column 4 Lines 21 and 22).

In regards to claim 7, Forbes discloses the following:

a) hot electron injection is used to program the floating gate transistor (For Example: See Column 7 Lines 28-30).

In regards to claim 8, Forbes discloses the following:

a) Fowler-Nordheim tunneling is used to program the floating gate transistor (For Example: See Column 7 Lines 55-57).

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In regards to claim 9, Forbes discloses the following:

- a) a plurality of semiconductor stacks arranged in rows and in columns, wherein each stack forms source, body, and drain regions of a respective floating gate transistor (For Example: See Figure 3a);
- b) a plurality of floating gates in trenches between the columns of semiconductor stacks, wherein the floating gates are separated from respective sides of the semiconductor stacks by a gate dielectric (340) (For Example: See Figure 3B); and
- c) control gate (335) separated from the respective floating gates by an intergate dielectric (For Example: See Figure 4).

In regards to claim 9, Forbes fails to disclose the following:

- a) a plurality of control gates overlaying the respective floating gates.

However, Kouznetsov discloses a semiconductor device that has a control gate overlaying a floating gate (For Example: See Figure 7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a control gate overlaying a floating gate as disclosed in Kouznetsov because it aids in increasing memory density (For Example: See Paragraph 24).

Additionally, since Forbes and Kouznetsov are both from the same field of endeavor, the purpose disclosed by Kouznetsov would have been recognized in the pertinent art of Forbes.

In regards to claim 10, Forbes discloses the following:

- a) etching is used to form the plurality of semiconductor stacks which extend vertically from a substrate (For Example: See Figure 7).

Additionally, the limitation of "etching is used to form the plurality of semiconductor stacks" makes it a product by process claim. The MPEP § 2113, states, "Even though product - by[-] process claims are limited by and defined by the process, determination of patentability is based upon the product itself. The patentability of a product does not depend on its method of

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production. If the product in product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product is made by a different process." *In re Thorpe*, 227 USPQ 964, 966 (Fed. Cir. 1985)(citations omitted).

A "*product by process*" claim is directed to the product per se, no matter how actually made, *In re Hirao and Sato et al.*, 190 USPQ 15 at 17 (CCPA 1976) (footnote 3). See also *In re Brown and Saffer*, 173 USPQ 685 (CCPA 1972); *In re Luck and Gainer*, 177 USPQ 523 (CCPA 1973); *In re Fessmann*, 180 USPQ 324 (CCPA 1974); and *In re Marosi et al.*, 218 USPQ 289 (CAFC 1983) final product per se which must be determined in a "*product by, all of*" claim, and not the patentability of the process, and that an old or obvious product, whether claimed in "*product by process*" claims or not. Note that Applicant has the burden of proof in such cases, as the above caselaw makes clear.

In regards to claim 11, Forbes discloses the following:

a) the respective floating gate transistors extend outwardly from a substrate with a source region formed proximally to the substrate, a body region above the source region, and a drain region above the body region (For Example: See Figure 3A).

In regards to claim 12, Forbes discloses the following:

a) two floating gates lie adjacent to each other in each trench between the columns of semiconductor stacks (For Example: See Figure 3A).

In regards to claim 12, Forbes fails to disclose the following:

a) one control gates overlays adjacent floating gates.

However, Kouznetsov discloses a semiconductor device that has a control gate overlaying a floating gate (For Example: See Figure 7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor

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device of Forbes to include a control gate overlaying a floating gate as disclosed in Kouznetsov because it aids in increasing memory density (For Example: See Paragraph 24).

Additionally, since Forbes and Kouznetsov are both from the same field of endeavor, the purpose disclosed by Kouznetsov would have been recognized in the pertinent art of Forbes.

In regards to claim 13, Forbes fails to disclose the following:

a) one floating gate lie in each trench between the columns of semiconductor stacks, and one control gate overlays the floating gate (For Example: See Figure 3A and Figure 4).

In regards to claim 13, Forbes fails to disclose the following:

a) one control gates overlays adjacent floating gates.

However, Kouznetsov discloses a semiconductor device that has a control gate overlaying a floating gate (For Example: See Figure 7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a control gate overlaying a floating gate as disclosed in Kouznetsov because it aids in increasing memory density (For Example: See Paragraph 24).

Additionally, since Forbes and Kouznetsov are both from the same field of endeavor, the purpose disclosed by Kouznetsov would have been recognized in the pertinent art of Forbes.

In regards to claim 14, Forbes discloses the following:

a) two floating gates lie adjacent to each other in each trench between the columns of semiconductor stacks (For Example: See Figure 3A).

In regards to claim 14, Forbes fails to disclose the following:

a) two corresponding control gates lie adjacent to each other above the floating gates.

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However, Kouznetsov discloses a semiconductor device that has a control gate overlaying a floating gate (For Example: See Figure 7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a control gate overlaying a floating gate as disclosed in Kouznetsov because it aids in increasing memory density (For Example: See Paragraph 24).

Additionally, since Forbes and Kouznetsov are both from the same field of endeavor, the purpose disclosed by Kouznetsov would have been recognized in the pertinent art of Forbes.

In regards to claim 15, Forbes discloses the following:

a) the array is a memory cell array with the source regions of common rows electrically connected to be first input selection lines the control gates electrically connected along the direction of the columns to be second input selection lines, and the drain regions of common columns electrically connected to output data lines (For Example: See Figure 1, Column 4 Lines 39-67, Column 5 Lines 1-25 and Column 6 Lines 25-65).

In regards to claim 18, Forbes discloses the following:

a) charges are stored in the floating gates to represent respective data in the memory cell array (For Example: See Column 7 Lines 8-28).

In regards to claim 19, Forbes discloses the following:

a) hot electron injection is used to selectively place charges in the respective floating gates, thereby programming the respective floating gate transistors (For Example: See Column 7 Lines 28-30).

In regards to claim 20, Forbes discloses the following:

a) a first conductivity type semiconductor pillar formed upon the substrate, wherein the pillar has top and side surfaces (For Example: See Column 1 Lines 64-67);

b) a first source/drain region of a second conductivity type formed in a portion of the pillar that is proximal to an interface between the pillar and the substrate (For Example: See Column 1 Line 67 and Column 2 Lines 1 and 2);

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c) a second source/drain region of a second conductivity type formed in a portion of the pillar that is distal to the substrate and separated from the first source/drain region (For Example: See Column 2 Lines 2-5);

d) a gate dielectric formed on at least a portion of one side surface of the pillar (For Example: See Figure 3B); and

e) a floating gate substantially adjacent to a body region defined by the separation between the first source/drain region and the second source/drain region, wherein the floating gate is separated from the body region by the gate dielectric (For Example: See Figure 3B).

In regards to claim 20, Forbes fails to disclose the following:

a) an intergate dielectric formed on a top surface of the floating gate.

However, Kouznetsov discloses a semiconductor device that has an intergate dielectric formed on top of the floating gate (For Example: See Figure 7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include an intergate dielectric as disclosed in Kouznetsov because it aids in keeping the device from shortening out (For Example: See Figure 7).

b) a control gate substantially overlaying the floating gate and insulated therefrom by the intergate dielectric.

However, Kouznetsov discloses a semiconductor device that has a control gate overlaying a floating gate separated by the intergate dielectric (See Figure 7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a control gate overlaying a floating gate separated by the intergate dielectric as disclosed in Kouznetsov because it aids in increasing memory density (For Example: See Paragraph 24).

Additionally, since Forbes and Kouznetsov are both from the same field of endeavor, the purpose disclosed by Kouznetsov would have been recognized in the pertinent art of Forbes.

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In regards to claim 21, Forbes discloses the following:

a) electrical charges in the floating gate controls electrical conduction between the first source/drain region and the second source/drain region (For Example: See Column 5 Lines 8 and 9).

In regards to claim 22, Forbes discloses the following:

a) the floating gate transistor is a data storage element in a programmable memory array with the data represented by charges stored in the respective floating gates (For Example: See Column 7 Lines 13-16).

4. Claims 16 and 17 are rejected under 35 U.S.C. 103(a) as obvious over Forbes et al. (U.S. Patent No. 5,936,274) in view of Kouznetsov et al. (U.S. Publication No. 2002/0142546), Cleaves et al. (U.S. Patent No. 6,580,124) and El Gamal et al. (U.S. Patent No. 5,510,730).

In regards to claim 16, Forbes discloses the following:

a) source regions of a common column electrically coupled to be selection lines, the control gates electrically coupled along the direction of the columns to be inputs, and the drain regions of a common row electrically coupled to be output lines (For Example: See Figure 1, Column 4 Lines 39-67, Column 5 Lines 1-25 and Column 6 Lines 25-65).

In regards to claim 16, Forbes fails to disclose the following:

a) logic array.

However, El Gamal et al. ("El Gamal") discloses a semiconductor device that has a logic array (For Example: See Column 2 Lines 5-13). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a logic array as disclosed in El Gamal because it aids in implementing logic functions (For Example: See Column 2 Lines 5-12).

Additionally, since Forbes and El Gamal are both from the same field of endeavor, the purpose disclosed by El Gamal would have been recognized in the pertinent art of Forbes.

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In regards to claim 17, Forbes discloses the following:

a) source regions of a common column electrically interconnected, the drain regions of a common row electrically coupled to be output lines, and the control gates interconnected along the direction of the columns (For Example: See Figure 1, Figure 2, Figure 3, Column 4 Lines 39-67, Column 5 Lines 1-25 and Column 6 Lines 25-65).

In regards to claim 17, Forbes fails to disclose the following:

a) field programmable logic array.

However, El Gamal discloses a semiconductor device that has a field programmable logic array (For Example: See Figure 7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a field programmable logic array as disclosed in El Gamal because it aids in implementing logic functions (For Example: See Column 2 Lines 5-12).

Additionally, since Forbes and El Gamal are both from the same field of endeavor, the purpose disclosed by El Gamal would have been recognized in the pertinent art of Forbes.

Response to Arguments

5. Applicant's arguments filed May 12, 2003 have been fully considered but they are not persuasive. First, Applicant argued that "a combination of the Forbes patent and the Kouznetsov application does not suggest an array of floating gate transistors." However, Forbes et al. ("Forbes") discloses a plurality of floating gates which is an array (For Example: See Column 1 Lines 10-67, Column 2 Lines 1-67 and Column 3 Lines 1-45).

Finally, Applicant argues that "neither Kouznetsov application nor the combination of the Forbes patent and the Kouznetsov application teaches or suggests Applicant's claimed invention. Moreover, the combination of the Forbes patent and the Kouznetsov application is based on hindsight as there is no suggestion to combine the Forbes patent with the Kouznetsov

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application.” In response to applicant's argument that there is no suggestion to combine the references, the examiner recognizes that obviousness can only be established by combining or modifying the teachings of the prior art to produce the claimed invention where there is some teaching, suggestion, or motivation to do so found either in the references themselves or in the knowledge generally available to one of ordinary skill in the art. See *In re Fine*, 837 F.2d 1071, 5 USPQ2d 1596 (Fed. Cir. 1988) and *In re Jones*, 958 F.2d 347, 21 USPQ2d 1941 (Fed. Cir. 1992). In this case, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Forbes to include a control gate overlaying a floating gate separated by the intergate dielectric as disclosed in Kouznetsov because it aids in increasing memory density (For Example: See Paragraph 24).

In response to applicant's argument that the examiner's conclusion of obviousness is based upon improper hindsight reasoning, it must be recognized that any judgment on obviousness is in a sense necessarily a reconstruction based upon hindsight reasoning. But so long as it takes into account only knowledge which was within the level of ordinary skill at the time the claimed invention was made, and does not include knowledge gleaned only from the applicant's disclosure, such a reconstruction is proper. See *In re McLaughlin*, 443 F.2d 1392, 170 USPQ 209 (CCPA 1971).

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Conclusion

6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire **THREE MONTHS** from the mailing date of this action. In the event a first reply is filed within **TWO MONTHS** of the mailing date of this final action and the advisory action is not mailed until after the end of the **THREE-MONTH** shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than **SIX MONTHS** from the date of this final action.

7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Monica Lewis whose telephone number is 703-305-3743. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on 703-308-4905. The fax phone number for the organization where this application or proceeding is assigned is 703-308-7722 for regular and after final communications. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

ML
July 15, 2003


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